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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Cameron et al.
SERIAL NO. 10/822,225 GROUP: 2891
FILED: April 9, 2004 EXAMINER: B. Smith
FOR: METHODS, PHOTORESISTS AND SUBSTRATES FOR ION-
IMPLANT LITHOGRAPHY (as amended)

Mail Stop: Amendments
Commissioner for Patents
P.O. Box 1450
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AMENDMENT

Applicants are in receipt of the Office Action dated September 25, 2006.

An amendment to the specification appears on page 2 of this paper.

A listing of pending claims begins on page 3 of this paper.

Remarks begin on page 9 of this paper.

Cameron et al.
U.S.S.N. 10/822,225
Page 2

Please amend the title to read as follows:

--METHODS, PHOTORESISTS AND SUBSTRATES FOR ION-IMPLANT
LITHOGRAPHY--